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PATENT
Attorney Docket No.: SSI-02001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Maximilian A. Biberger *et al.*

Serial No.: 09/841,800

Filed: April 24, 2001

For: **METHOD OF DEPOSITING
METAL FILM AND METAL
DEPOSITION CLUSTER TOOL
INCLUDING SUPERCRITICAL
DRYING/CLEANING MODULE**

) Group Art Unit: 2812

) Examiner:

) **TRANSMITTAL LETTER**

) 260 Sheridan Avenue, Suite 420
) Palo Alto, California 94306
) (650)833-0160

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Enclosed please find a Supplemental Information Disclosure Statement, and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-21-01

By: Thomas B. Haverstock
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicants

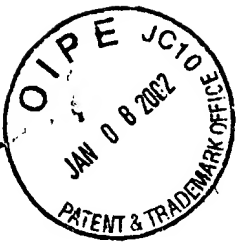
CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington D.C. 20231

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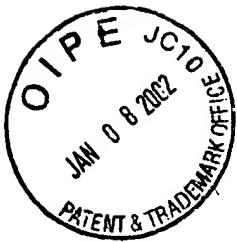
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Examiner:

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT

260 Sheridan Avenue, Suite 420
Palo Alto, California 94306
(650)833-0160

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicant has become aware of the following printed publications which may be material to the examination of this application:

- U.S. Patent No. 4,219,333;
- U.S. Patent No. 4,877,530;
- U.S. Patent No. 4,933,404;
- U.S. Patent No. 5,201,960;
- U.S. Patent No. 5,238,671;
- U.S. Patent No. 5,250,078;
- U.S. Patent No. 5,269,815;
- U.S. Patent No. 5,298,032;
- U.S. Patent No. 5,312,882;

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HAVERSTOCK & OWENS LLP.

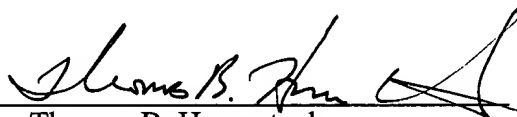
Date: 12-04-01 By: Juan D. Rios

- U.S. Patent No. 5,339,844;
- U.S. Patent No. 5,370,742;
- U.S. Patent No. 5,412,958;
- U.S. Patent No. 5,474,812;
- U.S. Patent No. 5,486,212;
- U.S. Patent No. 5,505,219;
- U.S. Patent No. 5,509,431;
- U.S. Patent No. 5,669,251;
- U.S. Patent No. 5,676,705;
- U.S. Patent No. 5,683,473;
- German Publication No. DE 39 04 514 C2;
- German Publication No. DE 39 06 724 C2;
- German Publication No. DE 39 06 735 C2;
- German Publication No. DE 39 06 737 A1;
- German Publication No. DE 40 04 111 C2;
- German Publication No. DE 43 44 021 A1;
- German Publication No. DE 44 29 470 A1;
- European Publication No. EP 0 518 653 B1;
- European Publication No. EP 0 620 270 A3;
- European Publication No. EP 0 679 753 B1;
- European Publication No. EP 0 711 864 B1;
- PCT Publication No. WO 93/14255;
- PCT Publication No. WO 93/14259;
- PCT Publication No. WO 93/20116; and
- PCT Publication No. WO 96/27704.

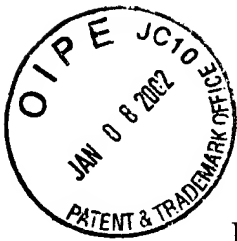
This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-21-01

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UNDER 37 CFR § 1.97(e)**

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Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

This certification is being made for the Supplemental Information Disclosure Statement accompanying this certification.

Certification

I hereby certify that no reference contained within this supplemental information disclosure statement was cited in a communication from a foreign patent office in a related foreign application, and, to the knowledge of the person signing the statement, after making reasonable inquiry, no reference contained within this supplemental information disclosure statement was known to any individual designated in §1.56(c) more than three months prior to the filing of this information disclosure statement. 37 C.F.R. 1.97(e)(2).

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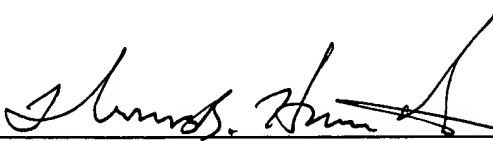
Date: 12-24-01 By: [Signature]

Identification of Person Making Certification

The person making this certification is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-21-01

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